



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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JUN 25 2003  
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In re the Application of:

ONO, Toshiaki et al.

Group Art Unit: 1765

Serial No.: 09/883,922

Examiner: ANDERSON, M.

Filed: June 20, 2001

P.T.O. Confirmation No.: 3735

For: **METHOD OF MANUFACTURING EPITAXIAL WAFER AND METHOD OF PRODUCING SINGLE CRYSTAL AS MATERIAL THEREFOR**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: June 20, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated February 26, 2003 for one month from May 26, 2003 to June 26, 2003.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

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